



THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Eiko Suzuki

Examiner: Brian Q. Le

Serial No.: 09/828,003

Art Unit: 2623

Filed: April 6, 2001

Docket: 14467

For: ID RECOGNITION
APPARATUS AND ID
RECOGNITION SORTER
SYSTEM FOR
SEMICONDUCTOR WAFER

Conf. No.: 5196
Dated: November 22, 2005

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT PURSUANT TO 37 C.F.R. § 1.111

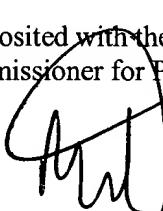
Sir:

In response to the final Office Action dated June 22, 2005, Applicant respectfully requests under the provisions of 37 C.F.R. § 1.111 that the above-identified Application be amended as follows and that the Application be allowed.

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on November 22, 2005.

Dated: November 22, 2005


Richard J. Danyko